



PATENT APPLICATION IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Sadayoshi HORII et al.

Application No.: 10/529,466

Docket No.: 123373

Filed: May 2, 2005

For: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE AND
SUBSTRATE PROCESSING APPARATUS


REQUEST FOR CORRECTION OF PALM RECORDS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

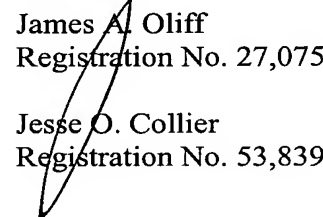
Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,



James A. Oliff
Registration No. 27,075



Jesse O. Collier
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JAO:JOC/yxm

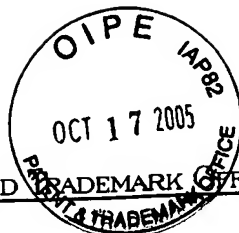
Date: October 17, 2005

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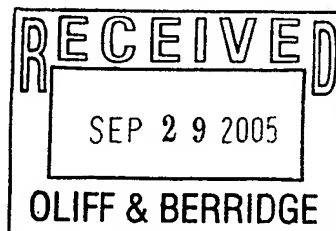
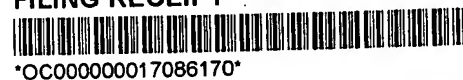
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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/529,466	03/29/2005 5/2/2005	2812	900	123373	11	11	2

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 CONFIRMATION NO. 8082
 FILING RECEIPT


OC000000017086170

Date Mailed: 09/28/2005

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Applicant(s)

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Assignment For Published Patent Application

Hitachi Kokusai Electronic, Inc., Nakano-ku, Tokyo, JAPAN

Power of Attorney: The patent practitioners associated with Customer Number 25944.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP03/13606 10/24/2003

Foreign Applications

JAPAN 2002-316154 10/30/2002

Projected Publication Date: 12/29/2005

Non-Publication Request: No

Early Publication Request: No

Title

~~Method for manufacturing semiconductor device and substrate processing system~~

Preliminary Class
438

MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE AND SUBSTRATE PROCESSING APPARATUS

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